Tool ID: 1803 Tool Location: 224

Equipment Information Sheet

Harrick Plasma Generator (2nd Floor)

Calls to staff phones will be automatically forwarded to Manager: Xinwei Wu 607-254-4934 their cell phones during accessible hours. At other times Backup: Aaron Windsor 607-254-4831

leave a message or send them an email.

SAFETY

• RF energy present

USAGE RESTRICTIONS

• Please contact the tool manager BEFORE using substrates other than glass, silicon or PDMS.

SCHEDULING/SIGN-UP RESTRICTIONS

Minimum Tool Time: 0 minutes

• None

MATERIALS COMPATIBILITY CATEGORY

Tool Category 5: Class A and B Metals and Compounds	
Allowed	Not Allowed
Tool category 1/1E, 2, 3, and 4 materials	
Silicon Based Substrates and Films	
III/V compound Semiconductors	
Glass Substrates	
PECVD and ALD Films	
Cured organics and baked Photoresist	
CNF Class A, B, and Refractory metals	
Exposed Gold, Silver, Copper	
Alkali and Alkaline Compounds	
Organic/Biology Molecules prepared- w/salt buffers	
High Vapor Pressure Materials (Mg, Ca, Zn)*	* Some tool restrictions on high vapor pressure materials may apply
Soft organic materials	

High Vapor Pressure Metals and Compounds are materials that have a vapor pressure above 1e-6 Torr at 400 C.

Additional Material Restrictions and Exceptions

- No flammable materials or liquids allowed
- No uncured PDMS allowed.

Last Updated: 07/15/2019